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PATENT & TRADEMARK OFFICE

Attorney Docket No. 0756-7210

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 1725
Hirotada OISHI	)	Examiner: S. Heinrich
Serial No. 10/684,416	)	
Filed: October 15, 2003	)	
For: LASER IRRADIATION APPARATUS	)	
AND METHOD OF	)	
MANUFACTURING	)	
SEMICONDUCTOR DEVICE BY	)	
USING THE LASER IRRADIATION	)	
APPARATUS	)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 30, 2005.

RESPONSE

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Official Action mailed August 30, 2005, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the shortened statutory period for response to December 30, 2005. Accordingly, the Applicant respectfully submits that this response is being timely filed.

The Applicant notes with appreciation the consideration of the Information Disclosure Statement filed on October 15, 2003.

Claims 1-47 are pending in the present application, of which claims 1, 11, 22, 30 and 38 are independent. For the reasons set forth in detail below, all claims are believed to be in condition for allowance. Favorable reconsideration is requested.

The Official Action rejects claims 1-47 as obvious based on the combination of the disclosure at pages 1-4 of the present specification, which the Official Action refers to as "Applicant's Admitted Prior Art (AAPA)," U.S. Patent No. 6,472,295 to Morris et al.